Refine Search

Search Results -
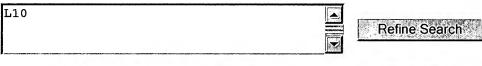
Terms	Documents
L5 and (partition or divide)	79

Database:

```
US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins
```

Search:

```
L10
```

Refine Search

Recall Text ⬍   Clear   Interrupt

Search History

DATE: Monday, November 21, 2005   Printable Copy   Create Case

Set Name side by side	Query	Hit Count	Set Name result set
DB=USPT; PLUR=YES; OP=ADJ			
L10	l5 and (partition or divide)	79	L10
DB=PGPB; PLUR=YES; OP=ADJ			
L9	l4 and (partition or divide)	44	L9
L8	semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region).clms	0	L8
DB=JPAB; PLUR=YES; OP=ADJ			
L7	semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region)	82	L7
DB=EPAB; PLUR=YES; OP=ADJ			
L6	semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region)	1	L6
DB=USPT; PLUR=YES; OP=ADJ			
L5	semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region)	1140	L5
DB=PGPB; PLUR=YES; OP=ADJ			
L4	semiconductor and (resist$ same (isolat$ near3 (film or layer))) and	594	L4

(active adj region)

DB=TDBD; PLUR=YES; OP=ADJ

L3   semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region)   0   L3

DB=DWPI; PLUR=YES; OP=ADJ

L2   semiconductor and (resist$ same (isolat$ near3 (film or layer))) and (active adj region)   45   L2

L1   semiconductor and (resist$ same (isolat$ near3 (film or layer)))   509   L1

END OF SEARCH HISTORY